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XP1000 LLD Characterization Preliminary Results

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H. W. Kugel and the NSTX Research Team

NSTX Monday Physics Meeting B-318, 12-APR-2010





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XP1000 Daily Outline

- Fri., 02APR10 started XP1000 Part 1B, R=50cm, LLD 220°C.
 - LLD 220°C, Did IR and Phantom calibrations
 - OSP control development
 - 3 ref at 2, 2MW and 3MW, raised LLD to 250°C

Mon., 05APR10 returned to 02APR10 conditions, LLD 220°C

- OSP control development, R=50, 63 cm
- $\quad \mbox{Reduced } \mathsf{D}\alpha \mbox{ relative to } 02 \mbox{APR10}$

• Tue, 06APR10, LLD rm temp, 250°C

- OSP control development R=50, 63 cm
- LLD @rm temp. Recovered ELM-free H-modes at R=35cm
- At R=50cm, improved OSP, increased front-end fuelling, reduced NBI
- Obtained ELM-fee H-mode flattops

• Wed., 07APR10, LLD 320°C

- OSP control development, R=50, 63 cm
- LLD raised to 320°C
- Little change in core n_e and edge T_e and n_e profiles
- Less flux consumption early in discharge

• Thu., 08APR10, LLD 320°C

- OSP control development
- LLD raised to 320°C, R=63cm , 70cm



NSTX 2010 Lithium Deposition Sequence



- Deposition on LLD ~5.6g (15% of 37g capacity)
- LITER mg/min calibration may be underestimating actual rate/total

LITER Calibration Presently Assumes Molecular Flow

-Actual Rate Increases Strongly Above 5mg/min Due to Viscous Flow



Downward Viewing Fast Phantom Camera Images





Downward Viewing Fast Phantom Camera Images



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Downward Viewing Fast Phantom Camera Images



plates at 250C, evening April 6th

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April 12, 2010



XP1000 Preliminary Summary

- 1. XP1000 began Friday afternoon 4/2/10 and continued through Thursday 4/08/10.
- 2. With LLD, lithium-free, IR emmissivity was measured by calibrating the Fast 2-Color IR camera, and Slow IR camera systems against the LLD thermocouples as the LLD temperature was raised from room temp to 220°C.
- 3. Simultaneously, the LLD visible reflectivity was measured using the Phantom fast cameras.
- 4. Then, lithium depositions on the LLD with temperatures ranging from room temperature to 220°C were started using the LITER system at a rate of 20-40mg/min.
- 5. When the LLD was heated above melting, the outgassing of D increased significantly indicating perhaps the effect of fuel and/or impurity accumulation from previous operations and/or the need for additional conditioning procedures.
- As lithium deposition increased, reproducible, ELM-free, H-mode, flattops were obtained with outer strike points at major radii of R=0.35m (near center stack), R=0.50m (mid inner divertor) and R=0.63m (the outer divertor tile ring just inboard of the LLD and outboard of the CHI gap).



XP1000 Preliminary Summary (cont.)

- 7. The ELM-free, H-mode, flattop conditions were obtained using :
 - improvements in the outer strike point control,
 - optimizing fueling in the early discharge,
 - and reducing NB power as lithium deposition increased.
- 8. LLD characteristics at temperatures up to 320°C were measured at these radii.
- 9. Although slight reductions were observed in the central and edge densities, no strong pumping due to the LLD was found at temperatures of up to 320°C, with strike points out R=0.70m and the initial LLD surface conditions.
- 10. These ELM-free discharges, however, exhibited noteworthy reproducible energy confinement times of 100 ms and reduced flux consumption early in these discharges.



D, LSN, OSP R=50cm, LLD=319°C





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Strike Point Location via Langmuir Probes

- Current density increase observed on Langmuir probes during strike point sweep
- Position roughly agrees with EFIT and IR camera data

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Determined that PCS system is about 3cm outboard of actual strike point location





Swept probes track n, T profiles as OSP moves

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Preliminary Outgassing Data

• RGA shows that deuterium, hydrogen entrained in LLD

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- Lab experiments showed rise in H₂, drop in H₂0 when lithium 'active' not observed conclusively on NSTX
- Although mass 2 seems to saturate and decrease during heating, mass 4 continues to increase
- Longer experiment necessary to more fully outgas LLD and measure various species inventories
- Also desirable to measure surface temperature w/IR and to quantify any effects of glcore and a surface temperature w/IR and to quantify any



XP1000 Next Steps

- The effects of gettered surface impurities, and increasing the rate and total Li deposition on the LLD continue under investigation.
- It may be necessary to briefly raise LLD above 300°C to dissolve impurities
- Above 305°C, Li evaporation from LLD begins to exceed typical LITER deposition rates (e.g. 20mg/min).
- Candidate next steps:
- 1. Perform LITER deposition during Maintenance Week sufficient to fill LLD to 50-60% of capacity.
- 2. With LITER on, take R=70m comparison shot.
- 3. Continue these discharges, turn off LITER, let the cold Li coating saturate, and measure effect of LLD liquid lithium pumping.



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